

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Kevin D. Lucas <i>et al.</i>	Group Art Unit:
Application No.:		Examiner:
Date Filed:	Concurrently Herewith	
Title:	PHOTOLITHOGRAPHY RETICLE DESIGN (As Amended)	

PRELIMINARY AMENDMENT

Commissioner For Patents
Alexandria, VA 22313

SIR:

Please enter this Preliminary Amendment in the above-entitled application.

Please enter the following amendments: